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PATENT
29925/37976

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Dong-Su Park and
Kwang-Seok Jeon

Serial No.: 10/021,322 ✓


Filed: December 12, 2001

For: Method for Manufacturing
Tantalum Oxy Nitride Capacitors

Group Art Unit: 3729

Examiner: Donghai D. Nguyen

) I hereby certify that this paper and the
) documents referred to as enclosed
) therewith are being deposited with the
) United States Postal Service as first class
) mail, postage prepaid, on December 3,
) 2003, in an envelope addressed to
) Commissioner for Patents, P.O. Box 1450
) Alexandria, Virginia 22313-1450



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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Please enter the following amendment in the above-referenced patent
application in response to the office action mailed on September 3, 2003.